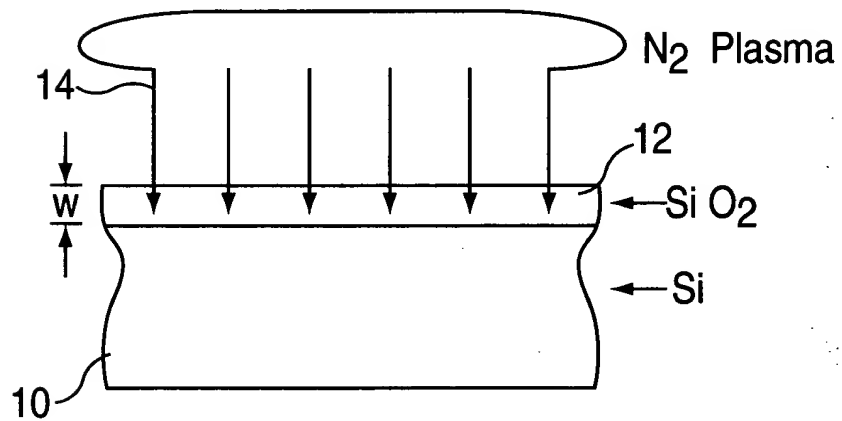
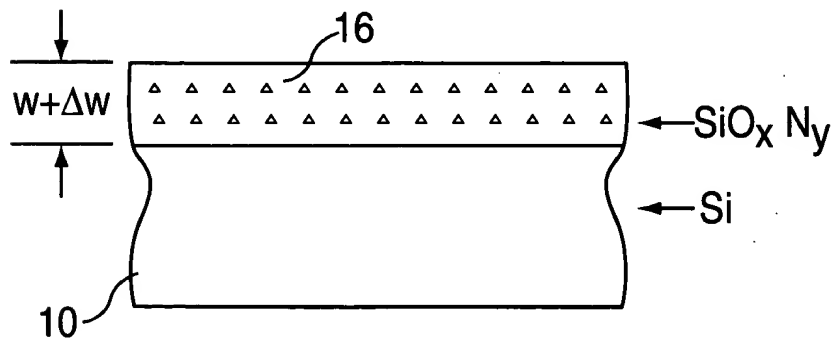


**FIG. 1a**  
(PRIOR ART)



**FIG. 1b**  
(PRIOR ART)



**FIG. 1c**  
(PRIOR ART)

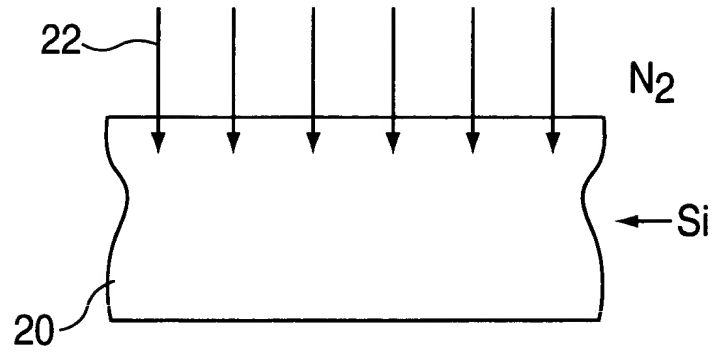


FIG. 2a

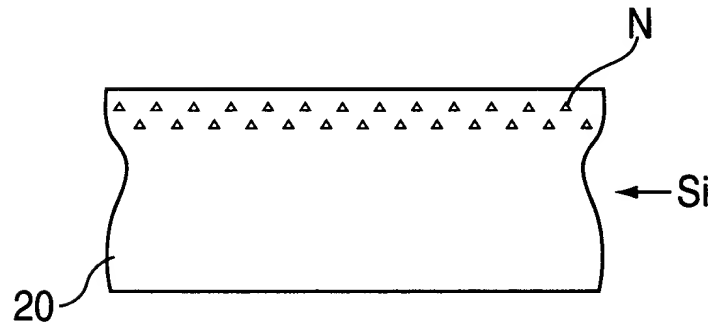


FIG. 2b

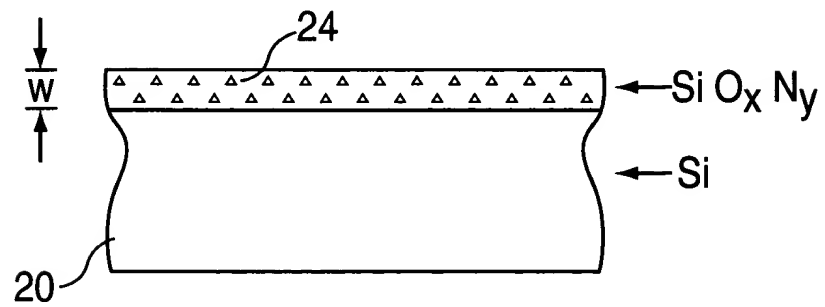


FIG. 2c

FIG. 2a

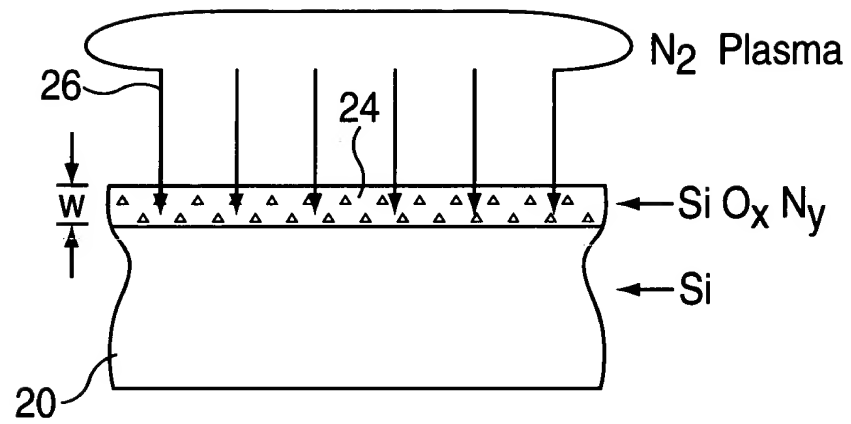


FIG. 2d

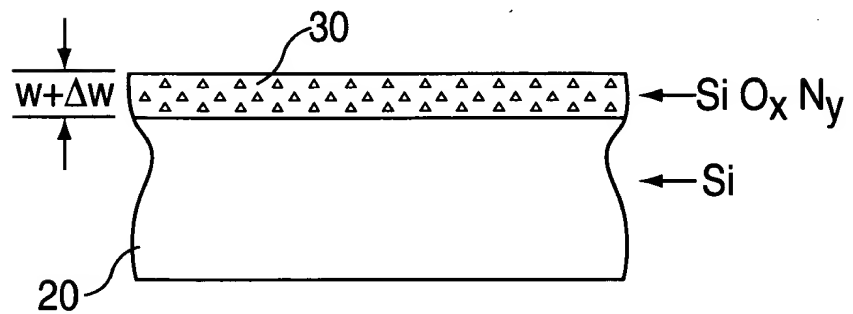


FIG. 2e

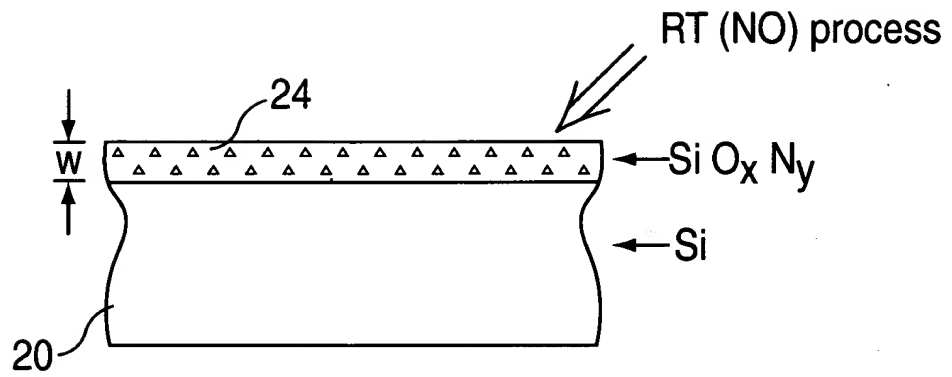


FIG. 3a

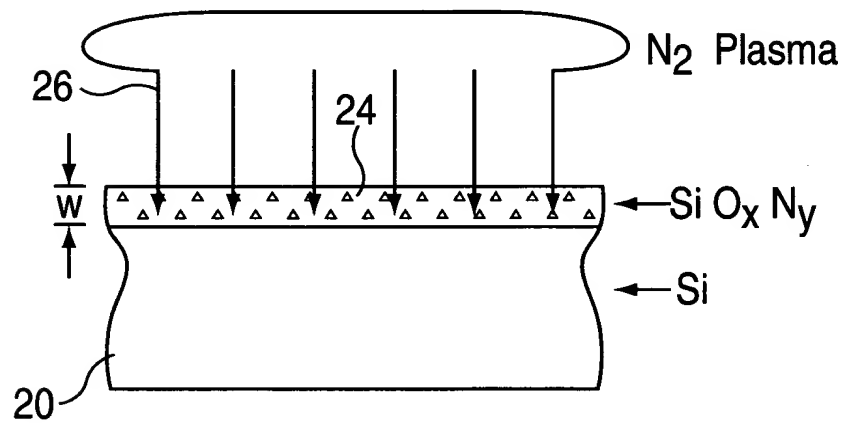


FIG. 3b

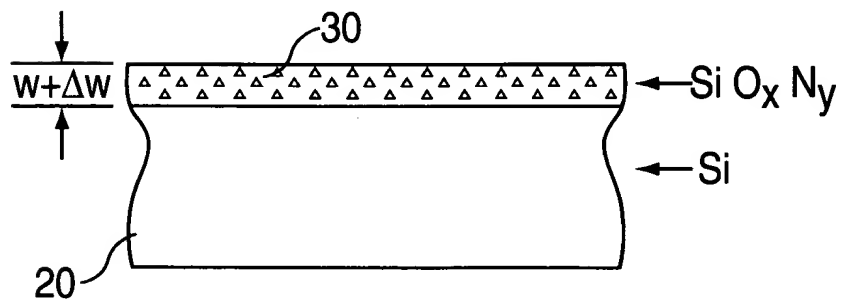
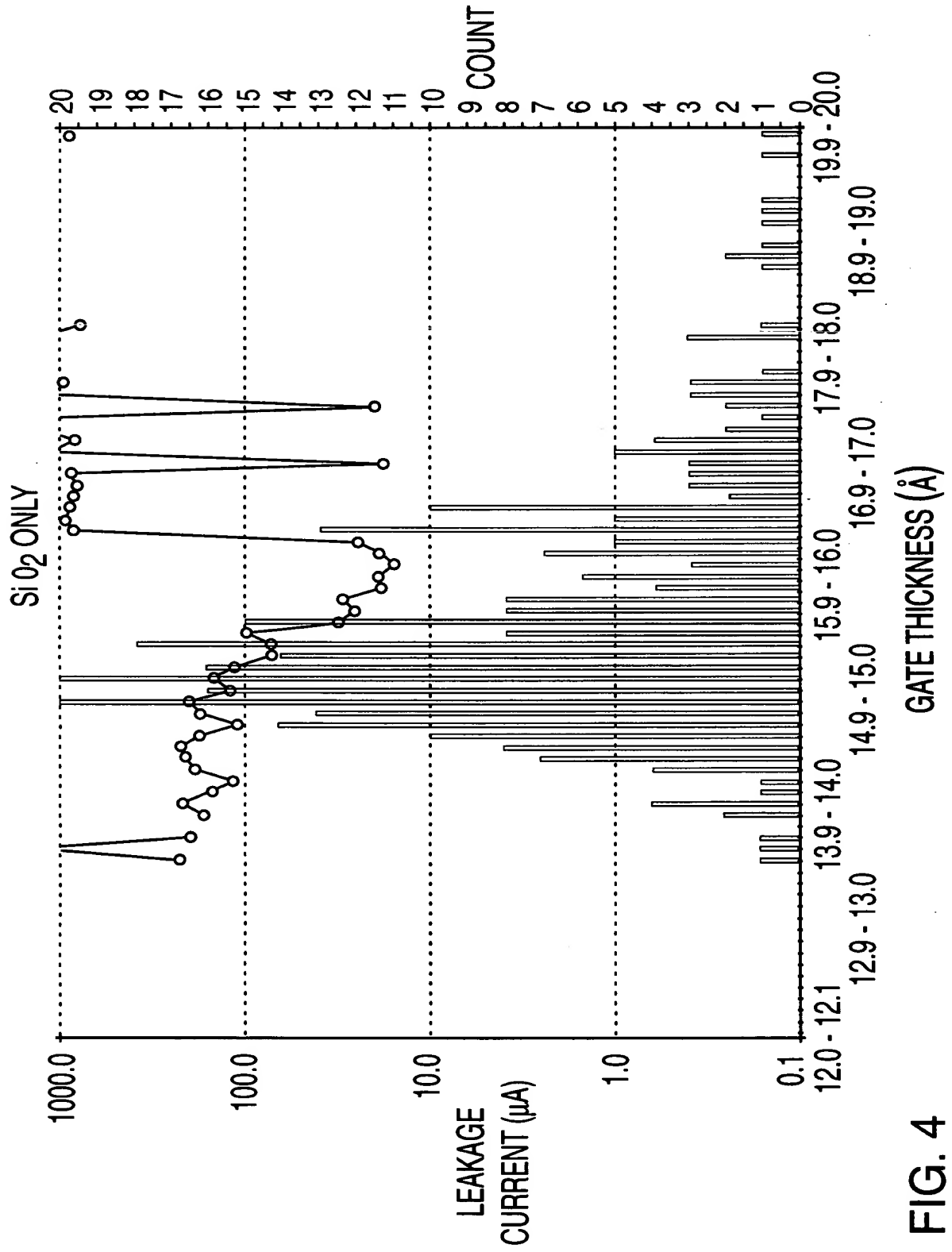


FIG. 3c



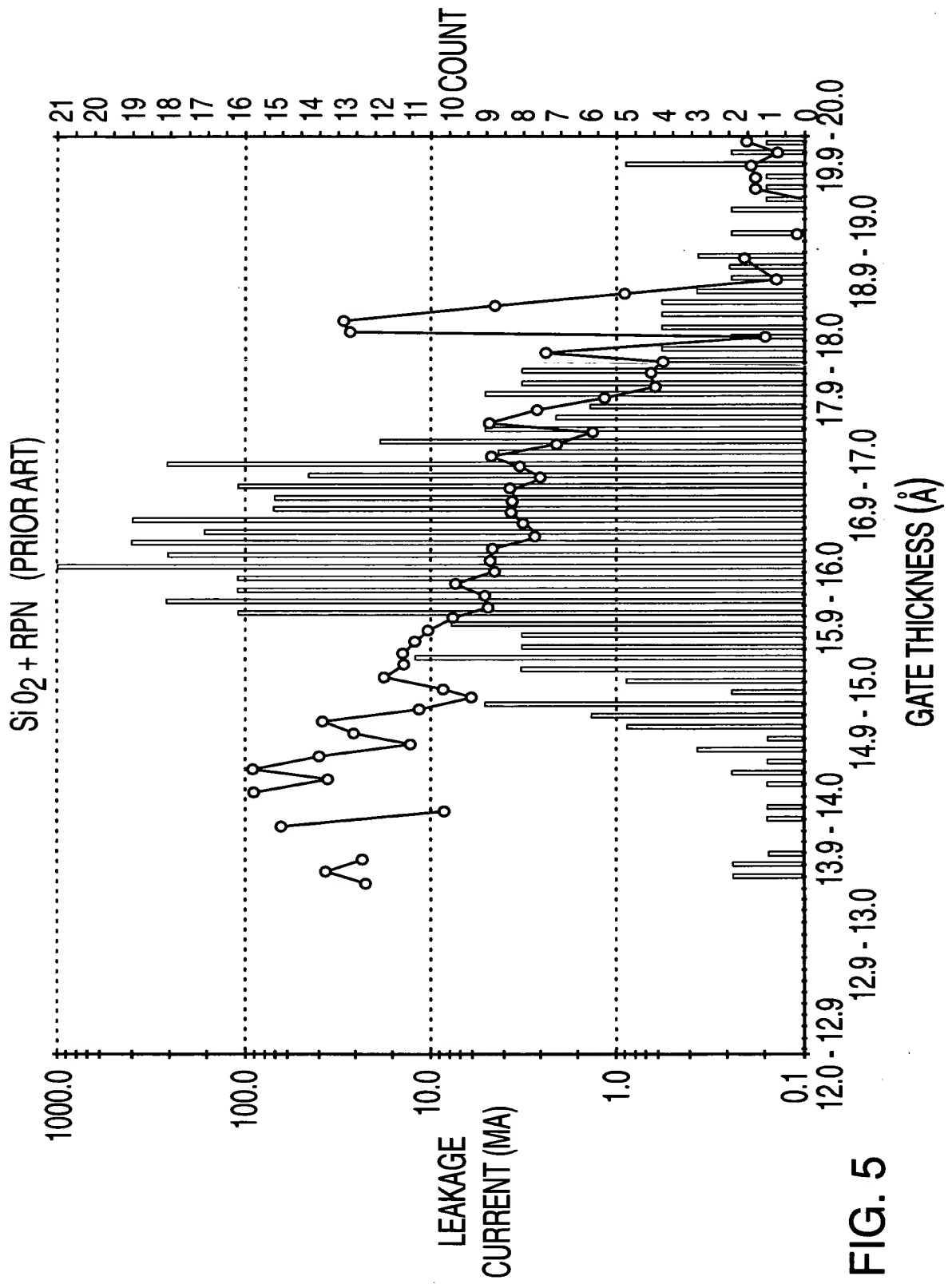


FIG. 5

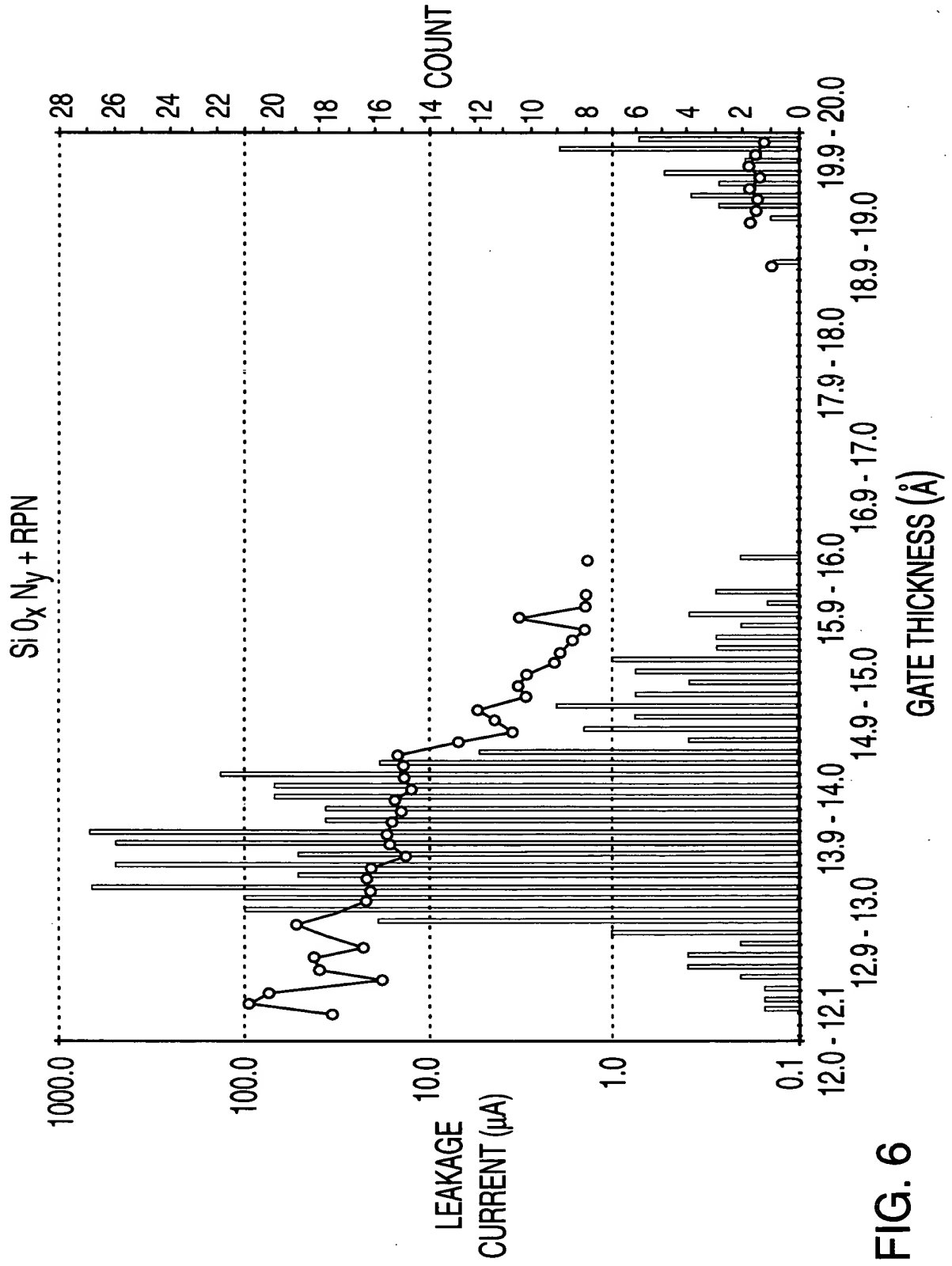


FIG. 6

UNIFORMITY OF GATE FILM

	<u>MEAN THICKNESS (nm)</u>	<u><math>\sigma</math></u>
RPN of Si O <sub>2</sub> (Dry)	1.74	0.287
RPN of Si O <sub>2</sub> (Wet)	1.68	0.115
RTNO	1.70	0.0293
RTNO +RPN@ 550°C	1.74	0.0246
RTNO +RPN@ 750°C	1.73	0.0296

FIG. 7



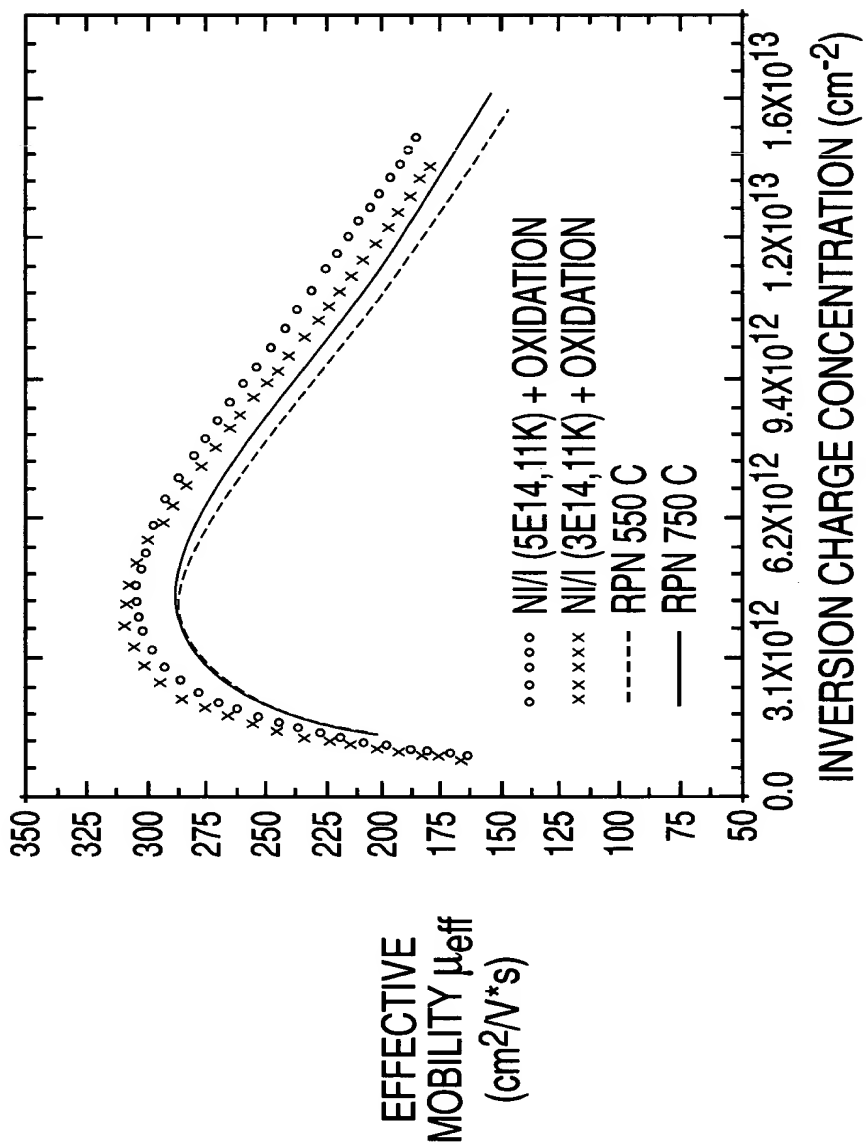


FIG. 8